

## Electronic Patent Application Fee Transmittal

Application Number:	10536621			
Filing Date:	26-May-2005			
Title of Invention:	Polishing pad and method of producing semiconductor device			
First Named Inventor/Applicant Name:	Masahiko Nakamori			
Filer:	Daniel E. Altman/Hiroko Isetani			
Attorney Docket Number:	UNIU40.005APC			

Filed as Large Entity

### **U.S. National Stage under 35 USC 371 Filing Fees**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
-------------	----------	----------	--------	----------------------

**Basic Filing:**

**Pages:**

**Claims:**

**Miscellaneous-Filing:**

**Petition:**

**Patent-Appeals-and-Interference:**

Notice of appeal	1401	1	540	540
Filing a brief in support of an appeal	1402	1	540	540

**Post-Allowance-and-Post-Issuance:**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Extension-of-Time:</b>				
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>1080</b>